

Docket No.: 065933-0046

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Tatsuhiko KOIDE

Application No.: 10/669,568

Filed: September 25, 2003

Customer Number: 20277

Confirmation Number: 4009

Group Art Unit: 2814

Examiner: Ginette Peralta

For: SEMICONDUCTOR DEVICE PROVIDED WITH A DIELECTRIC FILM INCLUDING POROUS STRUCTURE AND MANUFACTURING METHOD THEREOF

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☐ No additional fee is required.
☐ Applicant is entitled to small entity status under 37 CFR 1.27
☐ Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	20	26	0	\$50.00 =	\$0.00
Independent Claims	9	7	2	\$200.00 =	\$400.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$400.00

- ☒ Please charge my Deposit Account No. 500417 in the amount of \$400.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Tomoki Tanida

Limited Recognition No. L0098

Please recognize our Customer No. 20277 as our
correspondence address.

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Date: March 16, 2006
WDC99 1209734-1.065933.0046

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POROUS STRUCTURE AND MANUFACTURING METHOD THEREOF

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of December 16, 2005, please amend the above-
identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this
paper.

Remarks begin on page 9 of this paper.

03/17/2006 JADD01 00000072 500417 10669568
01 FC:1201 400.00 DA